

UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FILING DAT	TE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/633,276	07/31/2003		G. Laurie Miller	008252/USA CMP	3381
7590 06/30/2005			EXAMINER		
Patent Counsel			SCHINDLER, DAVID M		
Legal Affairs Dept. Applied Materials, Inc.				ART UNIT	PAPER NUMBER
Box 450A			2862		
Santa Clara, CA 95052			DATE MAILED: 06/30/2005		

Please find below and/or attached an Office communication concerning this application or proceeding.

-+/
-/-
T-

	Application No.	Applicant(s)				
Office Action Summany	10/633,276	MILLER ET AL.				
Office Action Summary	Examiner	Art Unit				
	David Schindler	2862				
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address				
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	within the statutory minimum of thirty (30) days ill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	ely filed s will be considered timely. the mailing date of this communication. O (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on 31 Ju	<u>ly 2003</u> .					
2a) ☐ This action is FINAL . 2b) ☐ This						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11, 45	3 O.G. 213.				
Disposition of Claims						
4) ☑ Claim(s) <u>1-53</u> is/are pending in the application. 4a) Of the above claim(s) is/are withdray 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☑ Claim(s) <u>1-53</u> are subject to restriction and/or expressions.						
Application Papers						
9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) access Applicant may not request that any objection to the Replacement drawing sheet(s) including the correction of the oath or declaration is objected to by the Examine 11).	epted or b) objected to by the Edrawing(s) be held in abeyance. See ion is required if the drawing(s) is obj	ected to. See 37 CFR 1.121(d).				
Priority under 35 U.S.C. § 119	•					
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the prior application from the International Bureau * See the attached detailed Office action for a list	s have been received. s have been received in Application ity documents have been received i (PCT Rule 17.2(a)).	on No ed in this National Stage				
Attachment(s)		Ti di				
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)	4) Interview Summary Paper No(s)/Mail Da					
Paper No(s)/Mail Date	6) Other:	.,				

Application/Control Number: 10/633,276 Page 2

Art Unit: 2862

DETAILED ACTION

Election/Restrictions

1. Restriction to one of the following inventions is required under 35 U.S.C. 121:

- Claims 1-22, drawn to an apparatus for chemical mechanical polishing, an eddy current sensing system, and an apparatus for semiconductor processing, classified in class 324, subclass 230.
- II. Claims 23-33, drawn to a method of in-situ profile control, classified in class 324, subclass 230.
- III. Claims 34-46, drawn to a semiconductor processing apparatus and a method, classified in class 324, subclass 230.
- IV. Claims 47-53, drawn to an apparatus for semiconductor processing, classified in class 324, subclass 230.

The inventions are distinct, each from the other because of the following reasons:

2. Inventions I and II and III and IV are related as subcombinations disclosed as usable together in a single combination. The subcombinations are distinct from each other if they are shown to be separately usable. In the instant case, invention I has a separate utility such as a device used to detect conductive film integrity. Invention II has a separate utility such as a device used to acquire thickness data for a conductive layer in a first region on a wafer where the first region has a length greater than a width. Invention III has a separate utility such as a device used to detect a distribution of

Page 3

impurities in a conductive layer. Invention IV has a separate utility such as a device used to determine surface roughness of a conductive layer.

See MPEP § 806.05(d).

- 3. Because these inventions are distinct for the reasons given above and the search required for Group I is not required for Groups II, III, and IV, the search required for Group II is not required for Groups I, III, and IV, the search required for Group III is not required for Groups I, II, and IV, and the search required for Group IV is not required for Groups I, II, and III, restriction for examination purposes as indicated is proper.
- 4. Because these inventions are distinct for the reasons given above and have acquired a separate status in the art because of their recognized divergent subject matter, restriction for examination purposes as indicated is proper.
- 5. Applicant is reminded that upon the cancellation of claims to a non-elected invention, the inventorship must be amended in compliance with 37 CFR 1.48(b) if one or more of the currently named inventors is no longer an inventor of at least one claim remaining in the application. Any amendment of inventorship must be accompanied by a request under 37 CFR 1.48(b) and by the fee required under 37 CFR 1.17(i).

Any inquiry concerning this communication or earlier communications from the examiner should be directed to David Schindler whose telephone number is (571) 272-2112. The examiner can normally be reached on M-F (8:00 - 5:00).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Edward Lefkowitz can be reached on (571) 272-2180. The fax phone

Application/Control Number: 10/633,276

Art Unit: 2862

number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

David Schindler

EDWARD LEFTOWITZ
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800

Page 4